The listing of claims will replace all prior versions, and listings, of claims in the application:

Listing of Claims:

1. (Original) A method of manufacturing a light-emitting device, comprising the steps of:

filling an organic electroluminescence material into an evaporation cell; and

heating the organic electroluminescence material in an inert gas atmosphere to form a light emitting layer on a substrate comprising the organic electroluminescence material.

2. (Original) A method of manufacturing a light-emitting device, comprising the steps of:

placing in a reaction chamber an evaporation cell containing an organic electroluminescence material and placing a shutter above an orifice of the evaporation cell;

heating the organic electroluminescence material in an inert gas atmosphere; and

opening and closing the shutter to form a light emitting layer on a substrate comprising the organic electroluminescence material.

3. (Original) A method of manufacturing a light-emitting device, comprising the steps of:

filling an organic electroluminescence material into an evaporation cell; and

heating the organic electroluminescence material in an inert gas atmosphere to selectively form a light emitting layer on a substrate comprising the organic electroluminescence material.

4. (Original) A method of manufacturing a light-emitting device, comprising the steps of:

placing in a reaction chamber an evaporation cell containing an organic electroluminescence material and placing a shutter above an orifice of the evaporation cell;

heating the organic electroluminescence material in an inert gas atmosphere; and

opening and closing the shutter to selectively form a light emitting layer on a substrate comprising the organic electroluminescence material.

5. (Original) A method of manufacturing a light-emitting device as claimed in claim 1, wherein more than one evaporation cell is provided.

6. (Original) A method of manufacturing a light-emitting device as claimed in claim 2, wherein more than one evaporation cell is provided.

7. (Original) A method of manufacturing a light-emitting device as claimed in claim 3, wherein more than one evaporation cell is provided.

8. (Original) A method of manufacturing a light-emitting device as claimed in claim 4, wherein more than one evaporation cell is provided.

9. (Original) A method of manufacturing a light-emitting device as claimed in claim 1, wherein the light-emitting device is a device selected from the group of: a personal computer, a video camera, a goggle-type display, a digital camera and cellular phone.

10. (Original) A method of manufacturing a light-emitting device as claimed in claim 2, wherein the light-emitting device is a device selected from the group of: a personal computer, a video camera, a goggle-type display, a digital camera and cellular phone.

11. (Original) A method of manufacturing a light-emitting device as claimed in claim 3, wherein the light-emitting device is a device selected from the group of: a personal computer, a video camera, a goggle-type display, a digital camera and cellular phone.

12. (Original) A method of manufacturing a light-emitting device as claimed in claim 4, wherein the light-emitting device is a device selected from the group of: a personal computer, a video camera, a goggle-type display, a digital camera and cellular phone.

13. (Original) A method of manufacturing a light-emitting device as claimed in claim 1, wherein the organic electroluminescence material is a small molecule material.

14. (Original) A method of manufacturing a light-emitting device as claimed in claim 2, wherein the organic electroluminescence material is a small molecule material.

15. (Original) A method of manufacturing a light-emitting device as claimed in claim 3, wherein the organic electroluminescence material is a small molecule material.

16. (Original) A method of manufacturing a light-emitting device as claimed in claim 4, wherein the organic electroluminescence material is a small molecule material.

17. (Original) A method of manufacturing a light-emitting device as claimed in claim 1, wherein the organic electroluminescence material is heated in an inert gas atmosphere at an atmospheric pressure.

18. (Original) A method of manufacturing a light-emitting device as claimed in claim 2, wherein the organic electroluminescence material is heated in an inert gas atmosphere at an atmospheric pressure.

19. (Original) A method of manufacturing a light-emitting device as claimed in claim 3, wherein the organic electroluminescence material is heated in an inert gas atmosphere at an atmospheric pressure.

20. (Original) A method of manufacturing a light-emitting device as claimed in claim 4, wherein the organic electroluminescence material is heated in an inert gas atmosphere at an atmospheric pressure.

21. (New) A method of manufacturing a light-emitting device, comprising the steps of:

filling an organic electroluminescence material into an evaporation cell;

heating the organic electroluminescence material in an inert gas atmosphere to form a light emitting layer on a substrate comprising the organic electroluminescence material; and

moving the evaporation cell and the substrate relative to each other during the heating step.

22. (New) A method of manufacturing a light-emitting device, comprising the steps of:

placing in a reaction chamber an evaporation cell containing an organic electroluminescence material and placing a shutter above an orifice of the evaporation cell;

heating the organic electroluminescence material in an inert gas atmosphere;

opening and closing the shutter to form a light emitting layer on a substrate comprising the organic electroluminescence material; and

moving the evaporation cell and the substrate relative to each other during the heating step.

23. (New) A method of manufacturing a light-emitting device according to claim 21, wherein the evaporation cell is moved during the heating step.

24. (New) A method of manufacturing a light-emitting device according to claim 22, wherein the evaporation cell is moved during the heating step.

25. (New) A method of manufacturing a light-emitting device according to claim 1, wherein the evaporation cell comprises a material selected from the group consisting of boron nitride, alumina and tungsten.

26. (New) A method of manufacturing a light-emitting device according to claim 2, wherein the evaporation cell comprises a material selected from the group consisting of boron nitride, alumina and tungsten.

27. (New) A method of manufacturing a light-emitting device according to claim 3, wherein the evaporation cell comprises a material selected from the group consisting of boron nitride, alumina and tungsten.

28. (New) A method of manufacturing a light-emitting device according to claim 4, wherein the evaporation cell comprises a material selected from the group consisting of boron nitride, alumina and tungsten.

29. (New) A method of manufacturing a light-emitting device according to claim 21, wherein the evaporation cell comprises a material selected from the group consisting of boron nitride, alumina and tungsten.

30. (New) A method of manufacturing a light-emitting device according to claim 22, wherein the evaporation cell comprises a material selected from the group consisting of boron nitride, alumina and tungsten.

31. (New) A method of manufacturing a light-emitting device according to claim 2, wherein a diameter of the orifice is several tens to several hundreds μm.

32. (New) A method of manufacturing a light-emitting device according to claim 4, wherein a diameter of the orifice is several tens to several hundreds μm.

33. (New) A method of manufacturing a light-emitting device according to claim 22, wherein a diameter of the orifice is several tens to several hundreds μm.